REPLY UNDER 37 CFR §1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re application of:

William Hong, et al.

Serial No.: 10/714,985

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Examiner: Thanh T. Nguyen

Confirmation No.: 2268

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Sir: .

I hereby certify that this correspondence (including any listed enclosures) is being faceimile transmitted (703-872-9306) to the United States Petent and Tredemerk Office on April 11, 2005.

Kelly A. Moreau

RESPONSE UNDER 37 CFR 81.116

This Response in submitted in reply to the Office Action mailed on February 2, 2005. (Please see the pages that follow).